

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0



Title of
Invention

Sacrificial Surfactanated Pre-Wet for Defect Reduction in a
Semi-Conductor Photolithography Developing Process

Application Number: 10/675419



Confirmation Number: 6182

First Named Applicant: John Kulp

Attorney Docket Number: CT-001

Search string: (6117486 or 6132940 or 6147010 or 6159662
or 6402398 or 6420101).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|-------------------------------------|----------|------------|------------|------------------|------|-------|----------|
| <input checked="" type="checkbox"/> | 1 | 6117486 | 2000-09-12 | Yoshihara | | 427 | 240 |
| <input checked="" type="checkbox"/> | 2 | 6132940 | 2000-10-17 | Mih et al. | | 430 | 394 |
| <input checked="" type="checkbox"/> | 3 | 6147010 | 2000-11-14 | Whitman | | 438 | 782 |
| <input checked="" type="checkbox"/> | 4 | 6159662 | 2000-12-12 | Chen et al. | | 430 | 313 |
| <input checked="" type="checkbox"/> | 5 | 6402398 | 2002-06-11 | Szajewski et al. | B1 | 396 | 604 |
| <input checked="" type="checkbox"/> | 6 | 6420101 | 2002-07-16 | Lu et al. | B1 | 430 | 326 |

Remarks

Note: Remarks are not for responding to an office action.

Applicants are of the opinion that no fee is due as a result of this Information Disclosure Statement. If any charges or credits are necessary to complete this communication, please apply them to Deposit Account No. 23-3000.

Signature

| Examiner Name | Date |
|------------------------|----------|
| <i>Joshua L. Davis</i> | 02/14/06 |

SUBSTITUTE FORM PTO-1449
(MODIFIED)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
CT-001SERIAL NO.
10/675,419INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(Use several sheets if necessary)

APPLICANT
John M. KulpFILING DATE
September 30, 2003GROUP
1756

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | PATENT NUMBER | | | | | | | ISSUE DATE | PATENTEE | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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| MD | A.A | 5 | 8 | 4 | 5 | 1 | 7 | 0 | 12/01/1998 | Ogata | 396 | 604 | 08/15/1997 |
| MD | A.B | 6 | 1 | 3 | 6 | 5 | 1 | 4 | 10/24/2000 | Phan et al. | 430 | 327 | 01/31/2000 |
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| | A.D | | | | | | | | | | | | |
| | A.E | | | | | | | | | | | | |
| | A.F | | | | | | | | | | | | |
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| | A.I | | | | | | | | | | | | |
| | A.J | | | | | | | | | | | | |
| | A.K | | | | | | | | | | | | |

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

| | | DOCUMENT NUMBER | PUBLICATION DATE | COUNTRY OR PATENT OFFICE | CLASS | SUBCLASS | TRANSLATION (YES/NO) |
|----|-----|--------------------|---------------------|-----------------------------|-------|----------|-------------------------|
| MD | A.L | WO 01/63365 | 08/30/2001 | PCT | G03F | 7/32 | |
| | A.M | | | | | | |
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| | A.O | | | | | | |
| | A.P | | | | | | |
| | A.Q | | | | | | |

OTHER DOCUMENTS (Including Author, Title, Date, Place of Publication)

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| | A.R | |
| | A.S | |
| | A.T | |

EXAMINER

Deborah Chalut Davis

DATE CONSIDERED

02/14/06

EXAMINER: Initial if citation considered, whether or not in conformance. Draw line through citation only if not in conformance and not considered.
Include a copy of this form with next communication to Applicant.